

Notice of References Cited

Application/Control No.

10/612,438

Applicant(s)/Patent Under
Reexamination
HU ET AL.

Examiner

SHANTELL HEIBER

Art Unit

2617

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,471,927	12-2008	Chen et al.	455/39
*	B	US-2004/0028006	02-2004	Kayama et al.	370/320
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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